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PATENT APPLICATION  
Docket No. 9898-314  
Client No. SS-20035-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al. Conf. No. 7097  
Serial No. 10/763,356 Examiner: Not yet assigned  
Filed: January 23, 2004 Art Unit: 2812  
For: ETCHING METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL LETTER**

Enclosed for filing in the above-referenced application are the following:

- Supplemental Declaration for Patent Application.
- Limited Recognition Under 37 CFR § 10.9(b)
- Return Postcard
- Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

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Respectfully submitted,

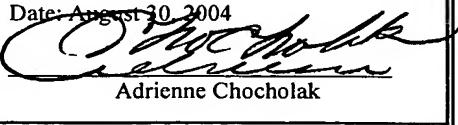
MARGER JOHNSON & McCOLLOM, P.C.



Hosoon Lee  
Limited Recognition Under 37 CFR § 10.9(b)

MARGER JOHNSON & McCOLLOM, P.C.  
1030 SW Morrison Street  
Portland, OR 97205  
503-222-3613

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Date: August 30, 2004



Adrienne Chocholak